

# SEMI® International MEMS Steering Group – General Meeting



**April 2004**

**Prof. Masayoshi Esashi**

**Tohoku University**

**SEMICON Europa 2004**

# 7<sup>th</sup> Microsystem MEMS Seminar(1)

Dec. 3 2003  
at Makuhari Messe I'ntl  
Conference room  
Chair: Prof. Masayoshi Esashi



## 7<sup>th</sup> Microsystem MEMS Seminar(2)

- Total 155 Attendees including 111 paid.
- Number of presentations 21
- Category of presentations
  - MEMS materials 4
  - MEMS Business model 4
  - Hot topics 5
  - MEMS equipment 8
- Related tabletop exhibition at MEMS pavilion 10

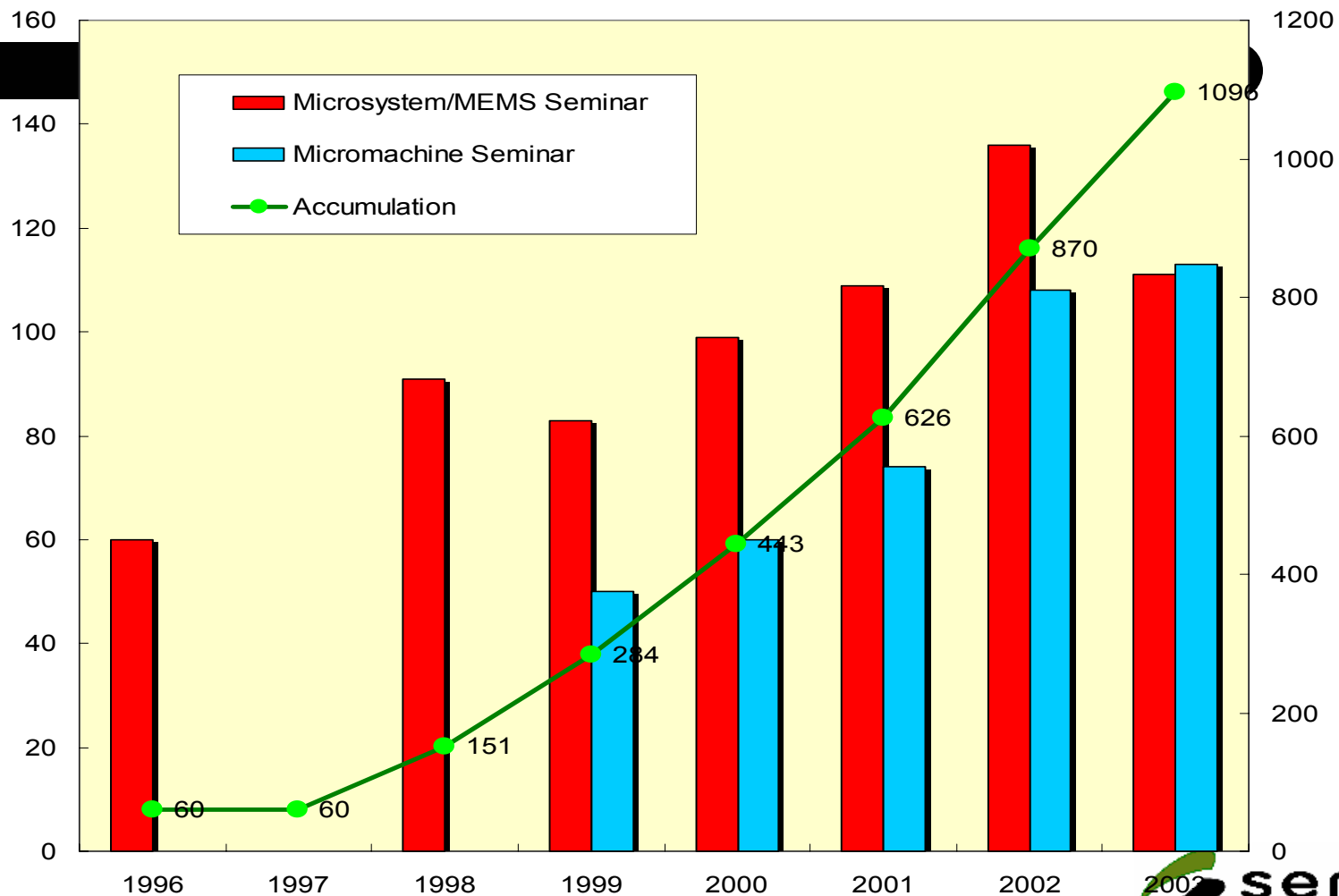
# Success Story in Japan (1)

- From 1999, SEMI Japan has held 2 annual MEMS seminars
- Micromachine Seminar (June at Osaka)
  - Chair Prof. Susumu Sugiyama (Ritsumeikan Univ.)
  - No Interpretation
  - Application oriented.
    - Ex.)01 MEMS in IT Industry. 02 Lab on a Chip
    - 03 MEMS industry began to run
  - Rapid Increase of attendees

## Success Story in Japan(2)

- Microsystem/MEMS Seminar
  - Dec. at Makuhari
  - Chair: Prof. Masayoshi Esashi (Tohoku Univ.)
  - Japan - US Simultaneous interpretation
  - Focus on MEMS manufacturing Technology
  - Average number of paid attendees is “98”.
  - Has drawn more than 100 paid attendees for recent 3 years.

# Technical Programs Paid Attendees



## 2004 Plan

- 6<sup>th</sup> Micromachine Seminar
  - Chair Prof. Susumu Sugiyama(Ritsumeikan Univ.)
  - June 16<sup>th</sup> as a conjunction event with SEMI Forum Japan
  - Theme “Power MEMS”
- 8<sup>th</sup> SEMI Microsystem/MEMS Seminar
  - Chair Prof. Masayoshi Esashi (Tohoku Univ.)
  - Dec 2<sup>nd</sup> at Makuhari Messe